



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant

Satoh et al.

Appl. No.

09/764,523

Filed

January 18, 2001

For

SEMICONDUCTOR-

PROCESSING DEVICE

PROVIDED WITH A REMOTE PLASMA SOURCE FOR SELF-

CLEANING

Examiner

Gentie E. Winter

Group Art Unit

1746

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

January 16, 2004

(Date)

O Lever REPLACEMENT AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

This is responsive to the final Office Action mailed October 22, 2003. Please amend the application in the following manner.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. After entry of the Amendments, Claims 39, 40 and 46-50 remain pending.

Remarks/Arguments begin on page 4 of this paper.